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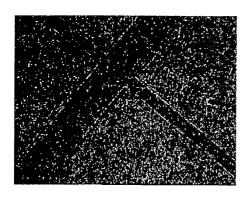
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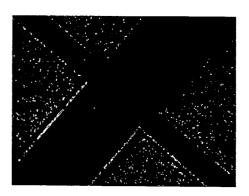
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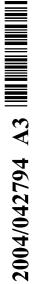
(54) Title: REMOVAL OF PARTICLE CONTAMINATION ON PATTERNED SLILICON/SILICON DIOXIDE USING SUPER-CRITICAL CARBON DIOXIDE/CHEMICAL FORMULATIONS





(57) Abstract: A cleaning composition for cleaning particulate contamination from small dimensions on semiconductor substrates. The cleaning composition contains supercritical CO₂ (SCCO₂), alcohol, fluoride source and, optionally, hydroxyl additive. Such cleaning composition overcomes the intrinsic deficiency of SCCO₂ as a cleaning reagent, viz., the non-polar character of SCCO₂ and its associated inability to solubilize species such as inorganic salts and polar organic compounds that are present in particulate contamination on wafer substrates and that must be removed from the semiconductor substrate for efficient cleaning. The cleaning composition enables damage-free, residue-free cleaning of substrates having particulate contamination on Si/SiO₂ substrates.





INTERNATIONAL SEARCH REPORT

International application No.

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Minimum documentation searched (classification system followed by classification symbols) U.S.: 134/2, 3, 36, 902		
Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched		
Electronic data base consulted during the international search (name of data base and, where practicable, search terms used) Derwent, STN		
C. DOCUMENTS CONSIDERED TO BE RELEVANT		
Category * Citation of document, with indication, where		Relevant to claim No.
X US 6,149,828 A (VAARTSTRA) 21 November 2 column 11, lines 1-24.	000 (21.11.2000), column 9, lines 1-12;	1-5, 14-16, 18, 19
· ·	US 6,306,564 B1 (MULLEE) 23 October 2001 (23.10.2001), column 4, lines 12-50; 1-5, 9, 10, 14-19, 21,	
Further documents are listed in the continuation of Box C.	See patent family annex.	
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Name and mailing address of the ISA/US Mail Stop PCT, Attn: ISA/US Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450 Facsimile No. (703) 305-3230	Authorized officer Gregory E. Webb Jean Proctos Telephone No. 571-272-1700 Paralegal Sp	

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